

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Sheet 1 of 1

37 CFR 1.501 INFORMATION DISCLOSURE CITATION IN A PATENT  (Use several sheets if necessary)						Docket Number (Optional) HRL025-DIV		Patent Number					
						Applicant Gregoire							
						Issue Date		Group Art Unit					
U.S. PATENT DOCUMENTS													
EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	5	1	5	4	0	2	3	10/13/1992	Sioshansi, Piran				
FOREIGN PATENT DOCUMENTS													
	DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
	0	4	9	6	5	6	4	07/29/1992	EP			YES	NO
	8	0	1	7	8	0	1	05/31/1996	JP				
	2	2	4	4	9	5	8	12/18/1991	GB				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)													
	GROT, S., A., et al. "Oxygen Based Electron Cyclotron Resonance Etching of Semiconducting Homoepitaxial Diamond Films," APPLIED PHYSICS LETTERS.												
	AMERICAN INSTITUTE OF PHYSICS. NEW YORK, US, vol. 61, no. 19, 9 November 1992, pp. 2326-2328, XP000324738, ISSN: 0003-6951.												
EXAMINER									DATE CONSIDERED				

**Burden Hour Statement:** This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.